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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomoko MIYAHARA et al.

Group Art Unit: 1792

Application No.: 10/768,153

Examiner: J. LUND

Filed: February 2, 2004

Docket No.: 118505

For: CARBON NANOTUBE MANUFACTURING APPARATUS AND METHOD, AND GAS DECOMPOSER FOR USE IN THE MANUFACTURING APPARATUS AND METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).
  - ☒ a. Attached is our Check No. 201067 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information.
- ☒ 2. One or more reference cited herein was cited in a foreign Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 1-4.
- ☒ 3. An English language Abstract of one or more non-English language references is attached. See References 3-4.

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- ☒ 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 4.

Respectfully submitted,



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